

Substitute for form 1449A-PTO		Complete if known	
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> <i>(Use as many sheets as necessary)</i>		Application Number	10/572,525
		Filing Date	March 20, 2006
		First Named Inventor	Kang, Xuejun
		Group Art Unit	<del>2811</del> 2823
		Examiner Name	<del>Unknown</del> Khiem D. Nguyen
Sheet 1 of 1		Attorney Docket No: 7989P002	

US PATENT DOCUMENTS					
Examiner Initial *	Cite No. <sup>1</sup>	USP Document Number	Publication or Issue Date MM-DD-YYYY	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear

FOREIGN PATENT DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document Country Code/Number/Kind Code (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear <sup>1,2</sup>

OTHER DOCUMENTS -- NON PATENT LITERATURE DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.			<sup>1,2</sup>
		CHU, CHEN F., et al., "Comparison of p-Side Down and p-Side Up GaN Light-Emitting Diodes Fabricated by Laser Lift-Off", <u>Japan Journal of Applied Physics</u> , Vol. 42, (02/15/2003), 147-150			
		LI, W H., et al., "Electrochemical deposition of Copper on patterned Cu/Ta(N)SiO2 surfaces for super filling of sub-micron features", <u>Journal of Applied Electrochemistry</u> , Vol. 31, (2001), 1395-1397			

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /KN/

EXAMINER

/Khiem Nguyen/

DATE CONSIDERED

04/27/2009